

Deep Eutectic Solvents (DES) Based On Sulphur For Silicon Surfaces As Alternative Lubricants TECNICO ISBOA





Mónica Antunes^{a,b}, Luís C. Branco^{*b}, Benilde Saramago^{*a}, Anne-Sophie Martins^a, Mariana de Sá Freire ^{a,b}, Fernando Caetano^{a,c}, Hermínio Diogo^a, Rogério Colaço^d

^a Centro de Química Estrutural, Instituto Superior Técnico, Universidade de Lisboa, Av. Rovisco Pais, 1049-001 Lisboa, Portugal

^b LAQV-REQUIMTE, Departamento de Química, Faculdade de Ciências e Tecnologia, Universidade Nova de Lisboa, Campus da Caparica, 2829-516 Caparica, Portugal,

^c Universidade Aberta, R. da Escola Politécnica, 147, 1269-001 Lisboa, Portugal

^d IDMEC-Instituto de Engenharia Mecânica, Departamento de Engenharia Mecânica, Instituto Superior Técnico, Universidade de Lisboa, Av. Rovisco Pais, 1049-001 Lisboa, Portugal.

LAQV @ REQUIMTI

* Corresponding authors: I.branco@fct.unl.pt; b.saramago@tecnico.ulisboa.pt

- DESs composed by a hydrogen bond acceptor (HBA) and a hydrogen bond donor (HBD), have recently being proposed as possible "green" alternatives to mineral oils and ionic liquids (ILs) in the lubrication of steel surfaces.
- New DESs containing sulphur units in their structure were prepared and tested in the lubrication of silicon surfaces which are relevant for nano/microelectromechanical systems (NEMS/MEMS).
- Four new DESs were prepared: [S_{4,4,2}][EtSO₄]:PEG, [C₂-THT][EtSO₄]:PEG, [C₂MIM][(S)-CSA]:PEG, and $[C_1-3-pic][MeSO_4]:PEG$.



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- Silicon substrate
- considerably more than PEG, which may constitute an advantage concerning their lubrication ability.
- Among the DESs, IL1:PEG is the less viscous fluid which may result from the low van der Waals interactions involving choline, the smallest cation, in agreement with its relatively high freezing temperature (-20°C).
- The lubrication regime may be considered boundary/mixed (low Z). The load is carried mainly by the surface asperities or partially by the asperities and by the lubricant film.
- For PEG the lubrication regime is closer to boundary lubrication, since there is a decrease of the CoF when Z increases.
- The poor behavior of IL2:Sulfolane and IL2:PEG may be attributed to the star-like [N_{4,4,4,4}] cation hindering the formation of a stable tribofilm.

should be due to the interaction of S-O group in the anions with the Si surface yielding the Si-O-S bond.

- For IL6:PEG, the pure IL and the DES led to similar CoFs, meaning that the tribological performance of the mixture depends on the boundary layer rather than its viscosity.
- IL5 led to CoF values greater than PEG, while a significant decrease was observed with IL5:PEG. The poor tribological performance of IL5 may result from internal friction in the liquid.

Conclusions

- Four new DES containing S units were efficiently prepared and characterized.
- IL5 and IL6 containing sulfate or sulfonate anions combined with PEG lead to DESs with good lubrication properties of Si surfaces.
- The overall characteristics of these compounds indicate that they may constitute an advantageous alternative to the traditional oils in microelectronics lubrication.

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